

RECEIVED
CENTRAL FAX CENTER

JUL 26 2006

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Serial No.:	10/710,827	Conf. No.:	4826
Filing Date:	08/05/2004	Art Unit:	2822
Applicant:	Michael J. MacDonald	Examiner:	Duong, Khanh B.
Title:	POLISHING INHIBITING LAYER FORMING ADDITIVE, SLURRY AND CMP METHOD	Docket No.:	FIS920040163 (IBMF-0064)

COMMISSIONER FOR PATENTS

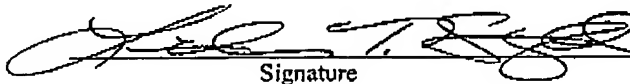
DESTINATION FACSIMILE NUMBER: 571-273-8300

Transmitted herewith is:

Response to Restriction Requirement in 03
pages

in the above identified application.

CERTIFICATION OF FACSIMILE TRANSMISSION

I hereby certify that this correspondence is being facsimile transmitted to the United States Patent and Trademark Office
on the date shown below.Linda T. Sagarese
(Person transmitting this correspondence)
SignatureJuly 26, 2006
Date

If you receive this correspondence in error or do not receive the entire transmission, please notify us at (518) 449-0044.

RECEIVED
CENTRAL FAX CENTER

JUL 26 2006

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of:	MacDonald, Michael J.	Conf. No.:	4826
Serial No.:	10/710,827	Art Unit:	2822
Filed:	08/05/2004	Dkt. #:	FIS920040163 (IBMF-0064)
Title:	Polishing Inhibiting Layer Forming Additive, Slurry and CMP Method	Examiner:	Duong, Khanh B.

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

RESPONSE TO RESTRICTION REQUIREMENT

Sir:

I. INTRODUCTORY COMMENTS

This paper is being filed in response to the Restriction Requirement dated 11 July 2006.

Applicant hereby provisionally elects Group I, claims 1-16, with traverse.